

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Yoichi TAMAKI et al.

Appln. No.:

Filed: Herewith

For: SEMICONDUCTOR DEVICE

* * *

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.56, and without any
assertion as to materiality or prior art effect, the
documents listed on the attached Form PTO-1449 are hereby
cited.

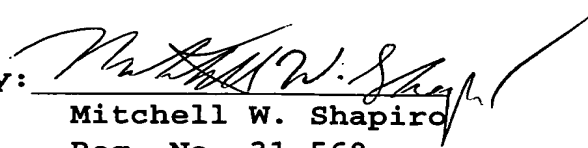
Documents AL and AM listed on the attached List are
cited in the specification, on pages 1-2, and their
relevance is indicated therein.

Respectfully submitted,

MWS:jab

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February 9, 2004

By:


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Reg. No. 31,568

FORM PTO-1449				Atty. Docket No. XA-10036		Appln. No.	
<u>LIST OF DOCUMENTS CITED BY APPLICANT</u>							
				Applicant Yoichi TAMAKI et al.			
				Filing Date Herewith		Group	
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-class	Filing Date
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
FOREIGN PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Country	Class	Sub-class	Translation
	AL	10-173040	6/26/98	Japan			Abstract
	AM	2002-57219	2/22/02	Japan			Abstract
	AN	2002-299466	10/11/02	Japan			Abstract
	AO						
	AP						
	AQ						
	AR						
	AS						
OTHER (including author, title, date, pertinent pages, etc.)							
	AT						
Examiner				Date Considered			
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							